

15W 1722



1110/97962

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re U.S. Patent Application

) Art Unit: 1722

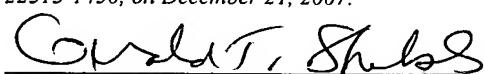
Applicant(s): Masafumi Ura

) Confirmation No.: 4524

Serial No.: 10/588,750

)
I hereby certify that this correspondence is
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Mailstop AMENDMENT / Commissioner for
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22313-1450, on December 21, 2007.

Filed: August 7, 2006

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Gerald T. Shekleton Reg. No. 27,466

For: **Method for Manufacturing Single Crystal
Semiconductor**

Examiner: Felisa Carla Hiteshew

)

AMENDMENT

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of September 21, 2007 has been carefully reviewed and the following amendments and remarks are made in response thereto: